

DAE *Zhu*



PATENT
Customer No. 22,852
Attorney Docket No. 7553.0044

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Hideki Tanaka)	Group Art Unit: 2878
)	
Application No.: 10/644,745)	Examiner: Unassigned
)	
Filed: August 21, 2003)	Confirmation No.: 6213
)	
For: PLASMA LEAK MONITORING)	
METHOD, PLASMA)	
PROCESSING APPARATUS AND)	
PLASMA PROCESSING METHOD)	
)	
)	

Commissioner for Patents
Washington, DC 20231

Sir:

STATUS INQUIRY


On December 6, 2004, Applicant's attorney faxed to the OIPE Customer Service Department of the PTO, fax no. 703-308-7751 a Petition to Withdraw the Holding of Abandonment Under 37 C.F.R. § 1.181(a). To date, Applicant has not received any communication relating to examination of this application.

In view of these circumstances, the undersigned attorney respectfully requests that the Office advise him of the status of the Petition to Withdraw the Holding of Abandonment as soon as possible in order to determine whether further action by the Applicant is required at this time.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: June 17, 2005

By: 
David W. Hill
Reg. No. 28,220